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PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:		NEW ASSIGNMENT			
NATURE OF CONVEYANCE:		ASSIGNMENT			
CONVEYING PARTY DA	TA	L			
		Name	Execution Date		
SHINSUKE KAWANISHI			03/11/2015		
YUSUKE OMINAMI			03/11/2015		
MASAHIKO AJIMA			03/11/2015		
HIROYUKI SUZUKI			03/11/2015		
RECEIVING PARTY DAT	A				
Name: HITACHI HIGH-TECHNOLOGIES CORPORATION					
Street Address:	24-14, NISHI SHIMBASHI 1-CHOME				
City:	MINATO-KU, TOKYO				
State/Country:	JAPAN				
Property Type		Number			
Application Number:	1	4431061]		
CORRESPONDENCE DA	Δ				
Fax Number:					
Correspondence will be	sent to	202)628-8844 the e-mail address first; if that is un t if that is unsuccessful, it will be ser			
Phone:	-	202-624-2500			
Email:		ouckler@crowell.com			
Correspondent Name: CROWELL & MORING LLP					
Address Line 1: 1001 PENNSYLVANIA AVENUE, NW					
Address Line 1:	1	UUT PENINSYLVANIA AVENUE, NW			
Address Line 1: Address Line 4:		VASHINGTON, D.C. 20004			
Address Line 4:	۷				
Address Line 4: ATTORNEY DOCKET NU	۷	VASHINGTON, D.C. 20004			
Address Line 4: ATTORNEY DOCKET NU NAME OF SUBMITTER:	۷	VASHINGTON, D.C. 20004 109701.67665US			
	۷	VASHINGTON, D.C. 20004 109701.67665US MICHAEL H. JACOBS			
Address Line 4: ATTORNEY DOCKET NU NAME OF SUBMITTER: SIGNATURE:	۷	VASHINGTON, D.C. 20004 109701.67665US MICHAEL H. JACOBS /Michael H. Jacobs/			

ASSIGNMENT (譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitachi High-Technologies Corporation, a corporation organized under the laws of Japan, located at 24-14, Nishi Shimbashi 1-chome, Minato-ku, Tokyo, Japan, receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi High-Technologies Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

CHARGED PARTICLE BEAM DEVICE, POSITION ADJUSTING METHOD FOR DIAPHRAGM, AND DIAPHRAGM POSITION ADJUSTING JIG

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted, to be held and enjoyed by said Hitachi High-Technologies Corporation, its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted, as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Technologies Corporation,

Signed on the date(s) indicated aside signatures:

	INVENTOR(S) (発明者フルネームサイン)	Date Signed (署名日)
1)	shinsuke KAWANISHI Shinsuke Kavanishi	3/11/2015
2)	YUSUKO OMINAMI YUSUke Ominami	3/11 /2015
3)	Masahiko AJIMA Masahiko ajima	3/11/2015
4)	Hiroyuki SUZUKI Hiroyuki Suzuki	3/11/201.5
5)	J	· · ·
6)		N
7)	· · · · · · · · · · · · · · · · · · ·	w
8)		
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10)		

RECORDED: 03/26/2015